

# EN.520.216 Homework 1

LJ Gonzales

February 2023

## 1 Manufacturing Problems

**Problem 1** 1. 90nm feature size means a size of  $24 \times 45\text{nm}$  by  $36 \times 45$  or  $1080$  by  $1620 = 1749600\text{nm}^2 \times \left(\frac{1 \times 10^{-9}\text{nm}}{1 \times 10^{-3}\text{mm}}\right)^2 = 1.7496e \times 10^{-6}\text{mm}^2$  per transistor. Hence we can have a maximum of  $\frac{9}{1.796 \times 10^{-6}} \approx 5144032$  transistors on the 3mm by 3mm chip.

This makes the assumption that transistors are allowed to be side-to-side with no space between them or that the necessary space is included in the provided area. Also, we assume the chip is single-layer.

2. Same as the previous, 5144032, with the added assumption that both nmos and pmos types are made to be the same size, which would probably not be the case.
- 3.

## 2 Device Physics Problems

**Problem 2** 1. The Fermi function gives the probability that a state *at a given energy* is filled with an electron. Because the total amount of available states at a given energy is large, this is basically equivalent to the fraction of states that are filled by an electron.

2. We use the Fermi function

$$\frac{1}{1 + e^{(E-E_f)/kT}}$$

with  $E = E_f + 0.225kT$ , giving  $\frac{1}{1+e^{0.225}} \approx 0.444$ .

3. Here  $E \gg E_f$  so we consider that most of the states at this level are empty.

**Problem 3** We know that  $n_i \approx \int_{E_c}^{\infty} g(E)e^{\frac{E-E_{fi}}{kT}} dE$  and  $n_d \approx \int_{E_c}^{\infty} g(E)e^{\frac{E-E_{fd}}{kT}} dE$ . But now if we just call  $E_{fd} = E_{fi} + \Delta E$  where  $E$  is just some constant that

represents how far the doped fermi level is relative to the intrinsic fermi level, we find that:

$$\begin{aligned} \frac{n_i}{n_d} &= \frac{\int_{E_c}^{\infty} g(E) e^{\frac{E-E_{fi}}{kT}} dE}{\int_{E_c}^{\infty} g(E) e^{\frac{E-(E_{fi}+\Delta E)}{kT}} dE} \\ &= \frac{1}{e^{-\Delta E/kT}} \frac{\int_{E_c}^{\infty} g(E) e^{\frac{E-E_{fi}}{kT}} dE}{\int_{E_c}^{\infty} g(E) e^{\frac{E-E_{fi}}{kT}} dE} = \frac{1}{e^{-\Delta E/kT}} \\ \ln \frac{10^{10}}{10^{17}} &= \frac{-\Delta E}{kt} \end{aligned}$$

From this we substitute our known values of k and T,  $8.6 \times 10^{-5}$  and 295, respectively, to find that  $\Delta E \approx 0.409$ , in other words the Fermi level is 0.409eV above the intrinsic fermi level of 1.1eV, for a total of about 1.5eV.



**Problem 4** 1.  $E_V$

2. The acceptor concentration can be calculated from the additional assumption  $p = N_A$  and the law of mass action  $np = n_i^2$ , such that  $N_A = p = \frac{(10^{10})^2}{10^{17}} = 10^3$  acceptors/cm<sup>3</sup>

**Problem 5** 1. With a similar calculation used in the previous problem, we find

$$E_g = -(2 \times 8.6 \times 10^{-5} \times 300) \ln\left(\frac{10^{13}}{5.2 \times 10^{15} \times 300^{3/2}}\right)$$

2. Here we need to first find the concentration of electrons as a result of this doping before inserting in the same equation. We find that  $n = \frac{n_i^2}{N_A} = \frac{(10^{10})^2}{5 \times 10^{14}} = 0.2 \times 10^6$  hence:

$$E_g = -(2 \times 8.6 \times 10^{-5} \times 300) \ln\left(\frac{0.2 \times 10^6}{5.2 \times 10^{15} \times 300^{3/2}}\right)$$